Search Notes



| App | lica | tion | /Contr | ol No |
|-----|------|------|--------|-------|
|-----|------|------|--------|-------|

10811222

Applicant(s)/Patent Under Reexamination

CHAO ET AL.

Examiner

TIPHANY B DICKERSON

Art Unit

3623

SEARCHED

| Class | Subclass | Date | Examiner |
|-------|----------|------|----------|
| | | | |

SEARCH NOTES

| Search Notes | Date | Examiner |
|---|-----------|----------|
| Searched capacity planning in semiconductor manufacturing environment | 1/8/2009 | TBD |
| capacity planning with upgrade technology | 1/8/2009 | TBD |
| Updated East Search | 8/16/2009 | TBD |

INTERFERENCE SEARCH

| Class | Subclass | Date | Examiner |
|-------|----------|------|----------|
| | | | |

| /TIPHANY B DICKERSON/ Examiner.Art Unit 3623 | |
|---|--|
| | |

U.S. Patent and Trademark Office Part of Paper No.: 20090816